

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

DONG-WOO SHIN et al.

Application No.: 10/749,775

Filed: December 30, 2003

For: METHOD FOR FABRICATING  
CAPACITOR OF SEMICONDUCTOR  
DEVICE

Customer No.: 20350

Confirmation No. 1063

Examiner: Jack S.J. Chen

Technology Center/Art Unit: 2813

AMENDMENT AFTER ALLOWANCE  
UNDER 37 CFR § 1.312

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date Uploaded: October 9, 2007

Sir:

In response to the Notice of Allowance mailed August 23, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.